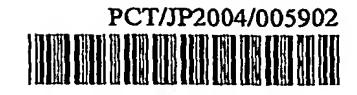
PATENT COOPERATION TREATY



PCT

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY (Chapter II of the Patent Cooperation Treaty)

•	tion	ATENT COOPERATION TRE	ATY		
~		PCT			
A		ONAL PRELIMINARY REPORT ON Chapter II of the Patent Cooperation Tr			
		(PCT Article 36 and Rule 70)			
Applic	ant's or agent's file reference 04-F-016PCT	FOR FURTHER ACTION	See Form PCT/IPEA/416		
Interna	tional application No. PCT/JP2004/005902	International filing date (day/month/year) 23 April 2004 (23.04.2004)	Priority date (day/month/year) 24 April 2003 (24.04.200		
Interna	ational Patent Classification (IPC) or n C23C 14/08, 14/34	ational classification and IPC			
Applic		AL INSTITUTE FOR MATERIALS	SCIENCE		
1.		minary examination report, established by this smitted to the applicant according to Article 3			
2.	This REPORT consists of a total of	4 sheets including this cover	sheet		
3.	This REPORT consists of a total of4 sheets, including this cover sheet. This report is also accompanied by ANNEXES, comprising:				
	a. Sent to the applicant and	to the International Bureau) a total of1_	sheets, as follows:		
	and/or sheets con Administrative In	ription, claims and/or drawings which have be taining rectifications authorized by this Authostructions). ersede earlier sheets, but which this Authority	ority (see Rule 70.16 and Section 607		
	beyond the discle Supplemental Bo	sure in the international application as filed,	as indicated in item 4 of Box No. I		
	,	nal Bureau only) a total of (indicate ty			
	readable form only, as in Administrative Instruction	ndicated in the Supplemental Box Relating t	ng and/or tables related thereto, in coo Sequence Listing (see Section 802		
	This report contains indications rela	ting to the following items:			
4.					
4.	Box No. I Basis of the re	eport			
4.	Box No. I Basis of the re	eport			
4.	Box No. II Priority		tive step and industrial applicability		
4.	Box No. II Priority Box No. III Non-establish	ment of opinion with regard to novelty, inven	tive step and industrial applicability		
4.	Box No. II Priority Box No. III Non-establish Box No. IV Lack of unity Box No. V Reasoned state	ment of opinion with regard to novelty, inven	•		
4.	Box No. II Priority Box No. III Non-establish Box No. IV Lack of unity Box No. V Reasoned state	ment of opinion with regard to novelty, invenor of invention ement under Article 35(2) with regard to nove explanations supporting such statement	•		
4.	Box No. II Priority Box No. III Non-establish Box No. IV Lack of unity Box No. V Reasoned state citations and citations and citations.	ment of opinion with regard to novelty, invenor of invention ement under Article 35(2) with regard to nove explanations supporting such statement	•		
4.	Box No. II Priority Box No. III Non-establish Box No. IV Lack of unity Box No. V Reasoned state citations and citations are citations and citations and citations are citations are citations and citations are citations are citations are citations and citations are c	ment of opinion with regard to novelty, invenor of invention ement under Article 35(2) with regard to novexplanations supporting such statement nents cited	•		
	Box No. II Priority Box No. III Non-establish Box No. IV Lack of unity Box No. V Reasoned state citations and citations are citations and citations and citations are citations are citations and citations are citations are citations are citations and citations are c	ment of opinion with regard to novelty, invention of invention ement under Article 35(2) with regard to novexplanations supporting such statement nents cited in the international application	elty, inventive step or industrial applic		
	Box No. II Priority Box No. III Non-establish Box No. IV Lack of unity Box No. V Reasoned state citations and citations and citations and citations and court Box No. VII Certain defect Box No. VIII Certain observables.	ment of opinion with regard to novelty, inventor of invention ement under Article 35(2) with regard to novexplanations supporting such statement ments cited as in the international application vations on the international application Date of completion	elty, inventive step or industrial applic		

International application No.

PCT/JP2004/005902

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

Box N	lo. I	В	asis of the report					
			o the language, this report is based on the international application in the language in which it was filed, unless icated under this item.					
	-		eport is based on translations from the original language into the following language, is language of a translation furnished for the purpose of:					
	[i	nternational search (under Rules 12.3 and 23.1(b))					
		p	oublication of the international application (under Rule 12.4)					
	Î	i	nternational preliminary examination (under Rules 55.2 and/or 55.3)					
fui	rnish ed are	ed to t e not a	to the elements of the international application, this report is based on (replacement sheets which have been the receiving Office in response to an invitation under Article 14 are referred to in this report as "originally filed" unnexed to this report):					
	,		ternational application as originally filed/furnished					
	-7		scription: 1-7, as originally filed/furnished					
		pages						
	_	pages* pages*						
_	_							
	7	the clai	oms: 5, 6, 8 , as originally filed/furnished					
		pages pages*						
		pages*						
		pages*						
2	71		awings:					
		nic dia	1-5 , as originally filed/furnished					
		pages*						
		pages*						
		a seque	ence listing and/or any related table(s) - see Supplemental Box Relating to Sequence Listing.					
	7	TTL						
3. 🛭	Z		mendments have resulted in the cancellation of:					
{			the description, pages					
			the claims, Nos. 2, 4					
			the drawings, sheets/figs					
			the sequence listing (specify):					
			any table(s) related to sequence listing (specify):					
4.		This report has been established as if (some of) the amendments annexed to this report and listed below had not been made, since they have been considered to go beyond the disclosure as filed, as indicated in the Supplemental Box (Rule 70.2(c)). The description, pages						
		<u></u>	the claims, Nos.					
			the drawings, sheets/figs					
}			the sequence listing (specify):					
			any table(s) related to sequence listing (specify):					
* 13	fiten	n 4 app	plies, some or all of those sheets may be marked "superseded."					

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

International application No. PCT/JP04/005902

Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement							
1. Statement							
y (N)	Claims	1, 3, 5-8	YES				
	Claims.		NO				
ve step (IS)	Claims	1. 3. 5-8	YES				
	Claims		NO				
ial applicability (IA)	Claims	1 3 5-8	YES				
	Claims	. 1, 3, 3-0	NO				
	y (N) ve step (IS)	(N) Claims Claims ve step (IS) Claims Claims Claims Claims Claims Claims	Claims Versite (IS) Claims Claims Claims Claims 1, 3, 5-8 Claims 1, 3, 5-8 Claims 1, 3, 5-8				

2. Citations and explanations (Rule 70.7)

Document 1: JP, 2003-119578, A (Independent Administrative Institution National Institute for Materials Science), 23 April, 2003 (23.04.03)

Document 2: Friction and Wear Properties of Partially Stabilized Zirconia with Solid Lubricant, (Y. Wang, et al.), Wear, 1993, Vol. 167, No. 1, pages 23-31

Document 3: Control of Frictional Force on Coating Films of Boron Nitride-Copper Complex in Ultra High Vacuum, (Masahiro Goto, et al.), Thin Solid Films, 2002, Vol. 405, pages 300-303

Document 4: Characteristics of Thin Films of Hexagonal Boron Nitride Mixed with Copper Controlled by a Magnetron Co-Sputtering Deposition Technique, (Masahiro Goto, et al.), Applied Surface Science, 2002, Vol. 185, pages 172-176

Claims 1, 3 and 5-8

The subject matters of claims 1, 3 and 5-8 are not disclosed in any of the documents cited in the ISR, and appear to be novel and to involve an inventive step. Particularly the feature of a copper oxide thin film material with low friction having a coefficient of friction of 0.06 or less is not described in any of the documents.

International application No.

PCT/JP04/005902

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

Box No. VIII Certain observations on the international application

The following observations on the clarity of the claims, description, and drawings or on the question whether the claims are fully supported by the description, are made:

The specification of the present application explains on page 4 a method for manufacturing an invented copper oxide thin film material with low friction, describing that the level of vacuum in forming film is set at "1x10⁻⁴ Pa – 1x10⁻⁶ Pa" and that "the operation conditions such as RF power, the distance between a substrate and a target, and the strength of a substrate can be specified as required for the plasma film-forming of copper oxide thin film mainly having CuO." Examples of the present application describe that, by means of sputtering with CuO target, copper oxide thin film having crystal orientation and a coefficient of friction of 0.06 or less could be produced on the condition that the level of vacuum is 1x10⁻⁶ Pa and the oxygen concentration level is 0 to 35%.

On the other hand, document 1 (JP, 2003-119578, A) by the same applicant explains that copper oxide thin film was produced in case of an oxygen concentration of 0% by means of the same method as the invention of the present application. Document 1 does not specify the level of vacuum in forming film, but the level of vacuum in the forming of film by sputtering is generally set at about 1×10^{-4} Pa $- 1 \times 10^{-6}$ Pa.

Comparing the invented manufacturing method for copper oxide thin film of the present application with the manufacturing method for copper oxide thin film described in document 1, both methods have no particular differences from each other, but the obtained copper oxide thin film in document 1 does not have crystal orientation, and has a coefficient of friction of 0.06 or more.

In view of the foregoing, the specification of the present application does not clarify under what special production conditions in comparison with document 1 copper oxide thin film having crystal orientation and a coefficient of friction of 0.06 or less could be first produced.